

[NAND FLASH MEMORY CELL ROW AND MANUFACTURING METHOD THEREOF]

Abstract

A NAND flash memory cell row and the manufacturing method thereof are provided. The memory cell row includes first and second stacked gate structures, control and floating gates, an inter-gate dielectric layer, a tunnel oxide layer, doping regions and source/drain regions. Each of the first stacked gate structures has an erase gate dielectric layer, an erase gate and a first cap layer. Each of the second stacked gate structure has a select gate dielectric layer, a select gate and a second cap layer. The control gate is disposed between each of the first stacked gate structures, and between each of the second stacked gate structures and the adjacent first stacked gate structure. The floating gate is disposed between the control gate and the substrate and has a concave surface with a sharp edge. The inter-gate dielectric layer is disposed between the control and floating gates. The tunnel oxide is disposed between the floating gate and the substrate. Furthermore, the doping regions are disposed under the first stacked gate structure, and the source/drain regions are disposed in the ex-

posed substrate at the outer side of the second stacked gate structure.